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Interactive comment on "A new parameterization of dust dry deposition over rough surfaces" by J. Zhang and Y. Shao

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We'd like to thank the anonymous referee for the critical and insightful comments to our manuscript. The details of our reply are shown in the supplement.

Please also note the supplement to this comment: http://www.atmos-chem-phys-discuss.net/14/C6086/2014/acpd-14-C6086-2014-supplement.pdf

Interactive comment on Atmos. Chem. Phys. Discuss., 14, 8063, 2014.

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